

Freeform optics enabling high dynamic scanning for line structuring of large substrates

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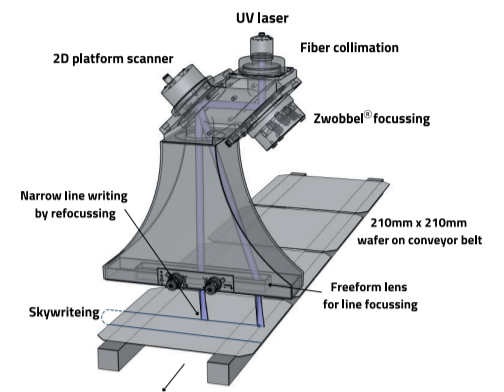
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ABSTRACT

- = Ultrashort pulsed lasers with 2 μm wavelength are ideal for material processing of plastics, such as welding, marking, and cutting
- = Scanning systems are essential for processing large substrates
- = Novel approach for line structuring using Zwobbel technology with freeform optics, developed in UKPino project, is presented
- = Approach aims for faster processing on larger substrates, particularly for roll-2-roll processes
- = Scanning across cylindrical lens generates strong image field curvature, which can be compensated by extending lens geometry to freeform lens
- = Processing field can be further extended by combining freeform lens with a deformable mirror that shifts focal position
- = Zwobbel technology, a piezo actuator-based deformable mirror with fast step responses (<2 milliseconds) and wafer scanning capability of up to 333 lines per second, has been selected
- = System generates sufficient lines on M12 substrates

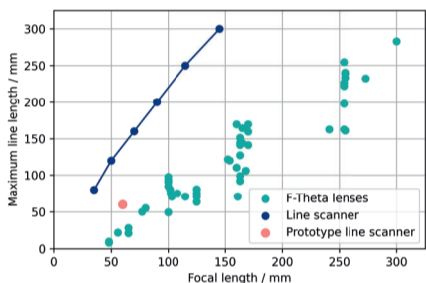
CONCEPT

- = Roll-2-roll applications need the highest scan speeds for line structuring
- = Precise polygonscanner with focus correction shall be used for 2D scanning
- = Freeform lens design is employed to generate narrow lines
- = Roll is structured during movement
- = Scanner needs fast speeds perpendicular to roll movement, and some roll speed compensation is needed



OPTICAL DESIGN

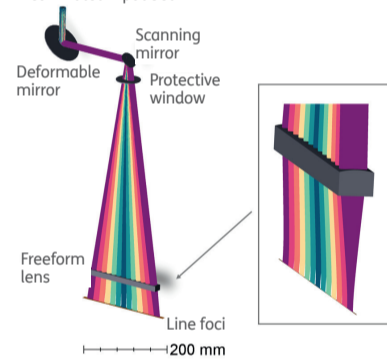
Limitations of state of the art optics



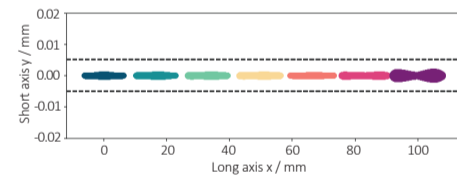
- = Conventional line writing with f-theta lenses requires short focal length for narrow lines
- = For given focal length, there is upper limit to field size and thus the maximum line length, regardless of the f-theta lens manufacturer
- = Extending line length without increasing line width requires novel approach
- = New line scanner, with focal length and field size highlighted in figure above, is presented
- = Scanner doubles line length compared to conventional f-theta lenses of same focal length

System layout

- = Collimated input beam deflected by deformable mirror at a 90° angle to hit scanning mirror
- = Beam passes through freeform, forming line focus
- = Depending on mirror angle, light passes through different segments of freeform lens
- = Freeform lens and Zwobbel amplitude are finely tuned for optimal manufacturability and low alignment sensitivity

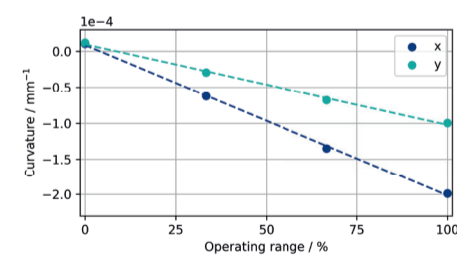


Spot diagrams demonstrate excellent focusing capabilities across whole field:

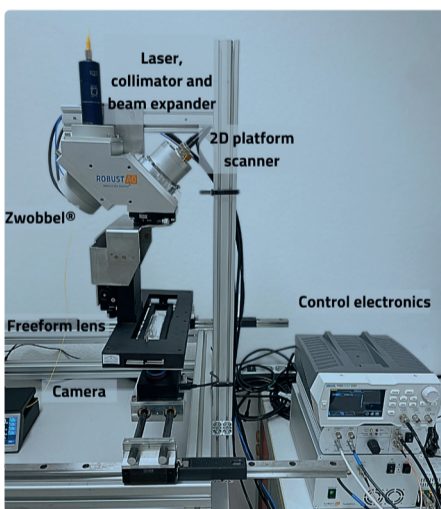


Parameterization of deformable mirror Zwobbel

- = Surface measurements of Zwobbel's mirror at different deformation stages are analyzed
- = Radii of curvature along long and short axes are used as basis for parameterization in optical design software



Experimental setup



DEFORMABLE MIRROR USABILITY

Objective

- = Evaluate deformable mirror technology in 2 μm roll-2-roll applications, focusing on high scan speeds

Technology

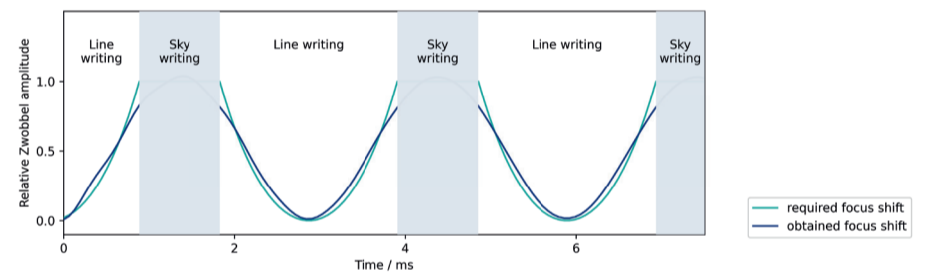
- = Mirror Type: Zwobbel deformable mirror, designed for fast focusing and space-saving.
- = Actuation: Piezoelectric actuators enable high speeds with excellent dynamics.
- = Hysteresis: An integrated absolute sensor ensures reproducible positioning

Mirror Design

- = 90° deflection with bi-conical deformation to avoid astigmatic aberrations.
- = Coating: Over 99.9% reflectivity between 1μm and 2μm with minimal polarization difference

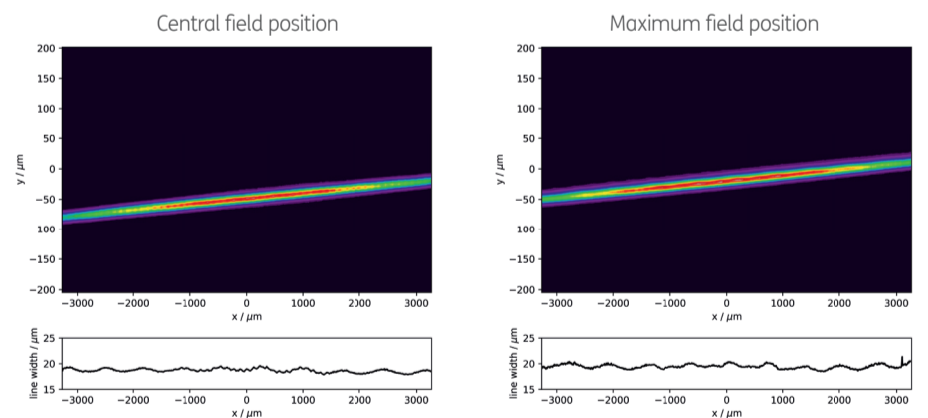
Measurement Methods

- = M² Measurement: 1064nm wavelength, beam diameter up to 15 mm for precise quality assessment
- = Dynamic Mirror Deflection: Capacitive sensor with 5kHz sampling frequency



PROOF OF CONCEPT DEMONSTRATION

- = Focal length freeform lens: 60 mm
- = Wavelength: 1064 nm
- = Input beam diameter: 10 mm
- = Scan field: 60 mm (limited by scanner)
- = Diffraction limited line width: 16 μm
- = Achieved line width: 18 – 21 μm



SUMMARY AND CONCLUSION

- = Novel line scanner utilizing freeform optics and Zwobbel technology has been developed to overcome limitations of conventional f-theta lenses, significantly extending line length without increasing line width
- = Integration of deformable mirror and freeform lens optimizes beam path, allowing for precise line focusing and compensation of image field curvature
- = Surface measurements of Zwobbel's mirror provide critical data for optical design, enhancing alignment and manufacturability of system
- = Ultrashort pulsed lasers at a 2 μm wavelength, combined with this advanced scanning system, offer powerful solution for high-speed processing of large plastic substrates
- = Collaboration within UKPino project has demonstrated potential of this technology for roll-2-roll processes, ensuring faster, more efficient material processing
- = With step response times < 2 ms and scanning capability of 333 lines per sec, Zwobbel technology enables precise and efficient line generation on M12 substrates, making it ideal for large-scale applications